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Attorney Docket No. UMC-96-279 CON  
Client/Matter No. 81848.0016.001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y.  
Wu, Water Lur and Shih-Wei Sun

Serial No. 09/546,174

Filed: April 11, 2000

For: HIGH DENSITY PLASMA CHEMICAL  
VAPOR DEPOSITION PROCESS

Group Art Unit: 1711

Examiner: Sergeant, Rabon A.

Confirmation No.: 4793

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P.O. Box 1450

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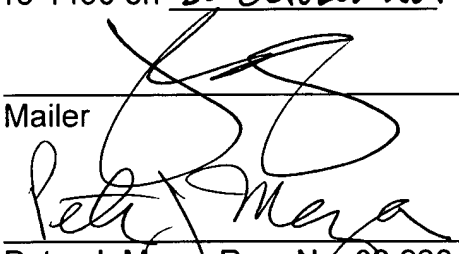
1. Request for Continued Examination with \$790 fee;
2. Information Disclosure Statement;
3. Form PTO/SB/08A, with reference and English translation;
4. Petition for Withdrawal from Issue Under 37 CFR 1.313 with \$130 fee;
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relating to the above application, were deposited as "Express Mail" Mailing Label No. EV331755906US, with the United States Postal Service, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 25 October 2004

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